

Germanium Texturing

_____, _____, _____*
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가

가 가 .

Germanium
1.11eV) . 가 silicon band gap (0.67eV Vs.
29 , 4 .

가 .
texturing sample MACE (Metal Assisted Chemical Etching) germanium wafer
SEM, AFM UV -Vis.
100nm RMS 30%

texturing sample MACE wafer germanium texturing